

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	Atty. Docket
ANTONIUS J.M. NELLISSEN	NL 020972
Serial No. 10/528,946	Group Art Unit 1795
Filed: March 23, 2005	Examiner: Stephen D. Rosasco
Conf. no.: 6415	

LITHOGRAPHIC METHOD FOR WIRING A SIDE SURFACE OF A
SUBSTRATE

Mail Stop Amendment
Commissioner for Patents
PO Box 1450
Alexandria, Virginia 22313-1450

Response to Restriction Requirement

Sir:

In response to the Office action mailed April 7, 2008,
please enter Applicant's response to the Examiner's
restriction requirement and amend the above-identified
application as follows:

Amendments to the Claims are reflected in the listing of
claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.